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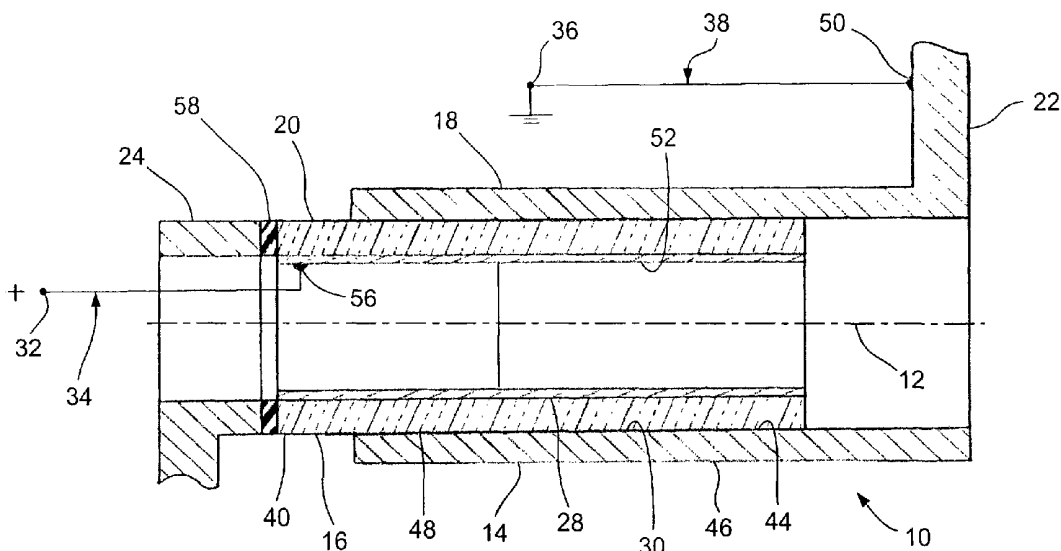
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(54) Title: PIEZOELECTRIC CYLINDER COUPLER FOR VARIABLY COUPLING TWO BODIES AND JOINT INCORPORATING THE COUPLER



(57) Abstract: A controlled collapse joint (60) includes a piezoelectric coupler (10) that frictionally couples two bodies (62, 64). The coupler includes concentric outer member (14) and inner member (16) mounted for relative motion on cooperating bearing surfaces (30, 44). The two surfaces engage each other with an interference fit that resists relative motion and frictionally couples the members (14, 16). One of the surfaces (30) is formed on a piezoelectric component (16) that moves towards or away the other surface when a voltage difference is applied to the piezoelectric component. The coupling of the two members (14, 16) is selectively adjustable by varying the applied voltage difference to increase or decrease the interference fit between the piezoelectric component (16) and the other member (14).



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CONTROLLED COLLAPSE JOINT

TECHNICAL FIELD

The present invention relates to a piezoelectric coupler
5 for selectively coupling two bodies and a joint incorporating
the coupler.

BACKGROUND ART

Piezoelectric material has a crystalline structure that
axially expands or contracts when a voltage difference is applied
10 along the axis. Whether the material expands or contracts
depends upon the polarity of the voltage difference. For
example, a positive voltage difference may cause the material to
expand and a negative voltage difference may cause the material
to contract. The greater the voltage difference, the greater the
15 deformation. When the voltage difference is removed the
structure returns to its initial undeformed state.

Devices that utilize the ability of piezoelectric materials
to selectively expand or contract are known. Such devices may
form couplers or joints that selectively couple or join two
20 bodies. The device is attached to one body. The piezoelectric
material expands and extends to engage the other body and couple
the two bodies together. The material contracts to uncouple the
two bodies. The expansion or contraction of the piezoelectric
material can be finely controlled by varying the applied voltage
25 difference.

In one known type of piezoelectric device a number of
piezoelectric elements are stacked together to form an element
stack having an initial stack height. The elements are each
connected to electrodes that apply a voltage difference from a
30 voltage source to opposite sides of the element. The voltage
difference increases the height of each element and so the
overall stack height increases. The stack height is controlled
by varying the voltage difference. The stack extends to engage
the end of the stack against the other member and apply a
35 coupling force to the other member.

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Piezoelectric stacks have a number of disadvantages that often render them unsuitable for joining or coupling two bodies. The large number of electrodes requires complicated and expensive wiring. The element stack must be supported in a housing, with the electrodes and wiring contained in the housing. Such an assembly is heavy and takes up a large amount of space. The stack force is applied over a small area and often a number of stacks must operate simultaneously to apply sufficient coupling force.

Thus, there is a need for an improved piezoelectric coupler for selectively coupling two bodies. The improved coupler should be compact and lightweight. The coupler should apply a coupling force over a large area, and should be simple to install and not require extensive wiring.

DISCLOSURE OF INVENTION

The present invention is directed to an improved coupler for coupling two bodies. The coupling force is applied over a relatively large area. The coupler is compact, lightweight and does not require extensive wiring. Structural elements and actuator elements of the coupler are incorporated in a self contained, integrated unit.

A coupler having features of the present invention includes an outer member mounted about an inner member for relative motion on mutually engaged concentric bearing surfaces. The two members are assembled together such that the surfaces engage each other with an interference fit that resists relative motion and frictionally couples the members.

One member includes a piezoelectric component having inner and outer walls. The surface of the one member is located on an inner or outer wall of the piezoelectric component. The surface on the piezoelectric component moves towards or away from the other surface when a voltage difference is applied across the inner and outer walls of the piezoelectric component and increases or decreases the interference fit. The frictional coupling of the two members is selectively controlled by varying the voltage difference applied across the walls of the

piezoelectric component to increase or decrease the interference fit between the two surfaces.

The coupling force is generated over a relatively large surface area and efficiently couples the members. Only one
5 piezoelectric component is needed to couple the two bodies and so the coupler is lightweight, compact and easily wired to a voltage source.

In possible embodiments of the present invention, only two electrodes are required to wire the piezoelectric component to a
10 voltage source. One electrode is electrically connected to the component outer wall and the other electrode is electrically connected to the component inner wall. The need to wire a large number of piezoelectric bodies is eliminated and the weight of the coupling is reduced.

15 In particularly advantageous embodiments, the other member is formed from an electrically conductive material, such as steel. The conductive material forms part of the electrical connection between the wall of the piezoelectric component engaging the conductive member and a terminal of a voltage
20 source. This allows an electrode to be easily attached to an exposed surface of the conductive member.

In preferred embodiments of the present invention the piezoelectric component forms a portion of the inner member. The outer member presses inwardly and compresses the piezoelectric
25 component. Conventional piezoelectric materials are stronger in compression than in tension, and so it is mechanically advantageous to have the piezoelectric component inside the outer member. However, if the piezoelectric material is sufficiently strong in tension, the piezoelectric component could form the
30 outer member. In such embodiments the interference fit could tension the piezoelectric component.

In an advantageous embodiment of the present invention, the coupler forms a portion of a controlled collapse joint that varies the coupling between two bodies in response to some
35 triggering event. The outer member is connected to one body and the inner member is connected to the other body. The joint enables the controlled coupling of one body with respect to the

other body in response to external events to advantageously regulate the coupling of the two bodies during the event.

The piezoelectric component is a piezoelectric cylinder that forms a portion of the inner member. The outer member is a steel
5 cylinder mounted on the piezoelectric cylinder for rotation, translation or combined rotation and translation about or along the piezoelectric cylinder. The outer and inner walls of the piezoelectric cylinder are electrically connected to a variable voltage system that forms a portion of a control system that
10 actively controls the coupling of the coupler.

The control system includes a computer that controls the output of the voltage source and a sensor that transmits data to the computer enabling the computer to resolve the triggering event. The computer varies the coupling of the two bodies in
15 response to the triggering event.

Other objects and features of the invention will become apparent as the description proceeds, especially when taken in conjunction with the accompanying drawings illustrating the invention, of which there are four sheets of drawings and two
20 embodiments.

BRIEF DESCRIPTION OF DRAWINGS

Figure 1 is a perspective view of a piezoelectric coupler made in accordance with the present invention;

Figure 2 is a sectional view of the piezoelectric coupler
25 taken along line 2--2 of Figure 1;

Figure 3 is a sectional view of the piezoelectric coupler taken along line 3--3 of Figure 1; and

Figure 4 illustrates a controlled collapse joint incorporating the piezoelectric coupler shown in Figure 1.

30 MODES FOR CARRYING OUT INVENTION

Figures 1-3 illustrate a piezoelectric coupler 10 made in accordance with the present invention. The coupler 10 couples two bodies about an axis of rotation 12.

The coupler 10 includes concentric outer and inner members
35 14 and 16 respectively that extend along the axis of rotation 12. The outer member 14 includes a cylindrical body 18 that is assembled over a cylindrical body 20 of the inner member 16 for

rotation about the axis 12. The outer body 18 is electrically
conductive and may be made of steel. The cylindrical bodies 18,
20, are assembled with an initial interference fit. The outer
member 14 is nonrotably connected to a first body by an arm 22
5 located on one end of the joint 10 for conjoint rotation about
the axis 12. The inner member 16 is nonrotatably attached to a
second body by a second arm 24 located on the other end of the
joint 10.

The inner cylindrical body 20 is a cylinder formed from
10 piezoelectric material. The piezoelectric cylinder 20 has an
inner cylinder wall 28 and an outer cylinder wall 30 separated by
the radial thickness of the cylinder. In operation, the inner
wall 28 is electrically connected to a positive terminal 32 of a
voltage source by a first electrical connection 34. The outer
15 wall 30 is electrically connected to a ground terminal 36 of a
voltage source by a second electrical connection 38.

The piezoelectric cylinder 20 extends from one end of the
outer cylindrical body 18 to a free end 40 adjacent the second
arm 24. The end 40 of the piezoelectric cylinder may include
20 conventional structure (not shown) such as teeth or splines
formed on the end of the piezoelectric cylinder 20 to connect the
piezoelectric cylinder with the second arm.

The outer member 14 has the first arm 22 integrally formed
with the cylindrical body 18. The cylindrical body 18 has inner
25 and outer cylindrical walls 44 and 46 respectively separated by
the radial thickness of the body 18. When unassembled, the
diameter of the inner wall 44 is slightly less than the diameter
of the outer wall 30 of the piezoelectric cylinder 20. When
assembled, the facing inner and outer walls 44, 30 engage each
30 other to form an initial interference fit. The walls press
against each other with a mutual contact pressure along a common
cylindrical interface 48.

The mutual contact pressure of the two cylindrical walls 44,
30 electrically connects the outer member 14 with the outer wall
35 30 of the piezoelectric cylinder 20 and forms a portion of the
second electrical connection 38. The electrical connection 38

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includes an electrode 50 fastened to the outside of the outer member 14 for connection to the ground terminal 36.

The first electrical connection 34 includes a thin cylindrical conductor, plating or conductive film 52 bonded to the inner wall 28 of the piezoelectric cylinder 20 by an electrically conducting bonding agent. The bonding agent electrically connects the film 52 with the inner wall 28. Second electrode 56 is attached to an exposed surface of the film 52 for connection to the positive terminal 32. In other possible embodiments of the coupler 10 a thin conductor, plating or conductive film can be bonded to the outer wall 30 of the piezoelectric cylinder 20 to form a portion of the second electrical connection 38.

Each of the mechanical connections may include electrical insulation that insulates the bodies attached to the members 14 and 16 from the electrodes 50, 56. In this embodiment the body attached to the inner member 16 is insulated by insulation 58 at the end 40 of the piezoelectric cylinder 20.

Figure 4 illustrates a controlled collapse joint 60 incorporating the coupler 10. The controlled collapse joint 60 acts to control the relative rotation of a movable body 62 about a stationary body 64. The movable body 62 is nonrotatably attached to arm 22 of the outer member 14 for conjoint rotation about the axis 12. The stationary body 64 is nonrotatably attached to arm 24 of the inner member 16. In other possible embodiments of the joint, the stationary body can be attached to arm 22 and the movable body attached to arm 24.

The joint 60 includes a control system 66 operatively connected to a variable voltage source 68 having terminals wired to the electrodes 56 and 50 of the coupler 10 respectively. The control system 66 includes a computer 70 operatively connected to the voltage source 68. The computer 70 selectively varies the coupling of coupler 10 in response to some triggering event.

In this embodiment, the control system 66 responds to an impact against the movable body 62 and includes a proximity sensor 72 operatively connected between the two members 14, 16 of the coupler 10 and the computer 70. The sensor 72 transmits a

data signal 74 to the computer 70 corresponding to the angular position of the outer member 14 with respect to the inner member 16. The data signal 74 enables the computer 70 to detect relative motion of the movable body 62 from an impact and calculate the speed and position of the body during the impact.

Operation of the controlled collapse joint 60 will now be described. The coupling of the two bodies by the coupler 10 is varied by the control system by varying the interference fit between the coupler members 14, 16. The joint 60 enables controlled deceleration or braking of the movable body 62 and yet minimizes the force of the impact against the body. The computer 70 monitors the motion of the movable body 62 and brakes the body in a controlled manner to prevent the impact forces acting on the body from exceeding acceptable levels.

The control system 66 can respond to impacts in one of two operating modes. In the first mode, the coupling of the two bodies 62, 64 by coupler 10 is increased during the impact to increase resistance to motion. The increased coupling more quickly brakes the movable body 62 and can decelerate the body in a controlled manner. In the second mode, the coupling of the two bodies 62, 64 by coupler 10 is decreased during impact to reduce resistance to motion. The reduced coupling enables the movable body 62 to rotate more easily during impact and reduces the impact force acting on the body.

The coupling of the two bodies by the coupler 10 is initially set by the control system 66 to prevent rotation of the outer member 14 about the inner member 16 during normal operating conditions. The control system 66 directs the voltage source 68 to generate a predetermined voltage difference across terminals 32, 36. The voltage difference is applied by the electrical connections 34 and 38 to the inner and outer cylinder walls of the piezoelectric cylinder 20. The piezoelectric cylinder 20 attempts to radially expand in response to the applied voltage difference. Expansion of the piezoelectric cylinder 20 is opposed by the cylindrical body 18 of the outer member 14. The interference between the two members at the interface 48 increases above the initial interference fit to an operating

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interference fit. The contact pressure at the interface 48 increases and friction between the members 14, 16 more tightly couples the members together. The operating fit is selected to ensure that the body 62 attached to the outer member 14 remains stationary during normal operating conditions.

An impact overcomes the frictional coupling between the two members 14, 16 and causes the body 62 to rotate with the outer member 14 about the axis 12. The proximity sensor 72 transmits the data signal 74 to the computer 70 indicating the initial motion of the now rotating body 62. The computer 70 detects the initial motion of the body 62 from the sensor data and determines that an impact has occurred.

When operating in the first mode, the computer 70 increases the voltage difference applied to the piezoelectric cylinder 20. The cylinder 20 attempts to further expand, and the interference fit at the interface 48 increases. The increased friction force generated at the interface 48 further resists the motion of the movable body 62 and quickly brings the movable body 62 to rest. The computer monitors the deceleration of the movable body and adjusts the voltage difference as needed to ensure that the force bringing the movable body to rest is acceptable.

When operating in the second mode, the computer 70 decreases the voltage difference applied to the piezoelectric cylinder 20. The piezoelectric cylinder radially contracts, with its outer wall 30 moving inwardly from the inner wall 44 of the cylindrical body 18. The interference fit at the interface 48 decreases. The friction force resisting motion of the moving body decreases and the coupling of the two bodies decreases. The moving body can now rotate with less resistance and forces acting on the body are reduced. The computer 70 monitors the deceleration of the movable body 62 via proximity sensor 72 and adjusts the voltage difference as required to ensure that the force braking the movable body is not excessive.

In other embodiments, the control system can respond to other types of trigger events in addition to or instead of impacts. Other sensors or data signals, including manual controls, accelerometers, bar code readers and the like may be

used for determining a trigger event to vary the coupling between the two bodies.

Although the coupler 10 includes concentric members that rotate with respect to each other, other embodiments of the present invention could have members that move axially or move with combined axial and rotational movement with respect to each other.

While I have illustrated and described a preferred embodiment of my invention, it is understood that this is capable of modification, and I therefore do not wish to be limited to the precise details set forth, but desire to avail myself of such changes and alterations as fall within the purview of the following claims.

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CLAIMS

1. A controlled collapse joint for selectively controlling the relative motion of two bodies, the joint comprising:

an outer member concentrically mounted on an inner member for relative motion about or along an axis;

the outer member having an inner wall;

the inner member comprising a piezoelectric cylinder having inner and outer walls, the piezoelectric cylinder being radially deformable in response to a voltage difference between the inner and outer walls of the cylinder;

the outer member mounted on the piezoelectric cylinder with the inner wall of the outer member and the outer wall of the piezoelectric cylinder engaging each other in an initial interference fit to frictionally couple the inner and outer members and resist relative motion of the two members;

means for mounting the outer member to a first body;

means for mounting the inner member to a second body;

a voltage source having terminals for generating a voltage difference across the terminals;

first and second electrical connections for applying the voltage difference generated by the voltage source between the inner and outer walls of the piezoelectric cylinder to radially deform the piezoelectric cylinder and thereby vary the interference fit from the initial interference fit to an operating interference fit;

the first electrical connection electrically connecting one terminal of the voltage source to the outer wall of the piezoelectric cylinder and the second electrical connection connecting the other terminal of the voltage source to the inner wall of the piezoelectric cylinder; and

a control system operatively connected to the voltage source for selectively setting the voltage difference applied to the piezoelectric cylinder.

2. The controlled collapse joint of claim 1 wherein the voltage difference has a polarity that causes the piezoelectric cylinder to deform radially outwardly.

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3. The controlled collapse joint of claim 2 wherein the operating interference fit is greater than the initial interference fit.

4. The controlled collapse joint of claim 1 wherein the outer member is formed from a material that conducts electricity and the outer member forms a portion of the first electrical connection.

5. The controlled collapse joint of claim 4 wherein the interference fit between the outer member and the outer wall of the piezoelectric cylinder electrically connects the inner wall of the outer member with the outer wall of the piezoelectric cylinder.

6. The controlled collapse joint of claim 1 wherein the second electrical connection includes a conductive film adhering to the inner wall of the piezoelectric cylinder.

7. A piezoelectric coupler for coupling two bodies, the coupler comprising:

a first member having a surface;

a second member concentric with the first member, the second member comprising a piezoelectric component having inner and outer walls, one of the walls cooperatively engaging the surface of the first member to enable relative motion of the two members on such surface and forming a first interference fit with such surface to frictionally couple the two members;

means for attaching the first member to a first body and means for attaching the second member to a second body;

first and second electrical connections for applying a voltage difference between the inner and outer walls of the piezoelectric member, the first electrical connection including a first electrode electrically connected to the one wall of the piezoelectric member and the second electrical connection including a second electrode electrically connected to the other wall of the piezoelectric member;

whereby when a voltage difference is applied across the two electrodes, the one wall of the piezoelectric member is urged towards or away from the surface of the first member and forms a second interference fit with the surface of the first member, the

second interference fit being different than the first interference fit to vary the coupling of the two members.

8. The piezoelectric coupler of claim 7 wherein the surface of the first member surrounds and engages the outer wall of the piezoelectric component.

9. The piezoelectric coupler of claim 8 wherein the first member is a conductor of electricity and forms a portion of the first electrical connection.

10. The piezoelectric coupler of claim 8 wherein the second electrical connection includes a conductive member on the inner wall of the piezoelectric component.

11. The piezoelectric coupler of claim 7 wherein the first member is formed from an electrically conductive material and forms a portion of the first electrical connection.

12. The piezoelectric coupler of claim 11 wherein the first electrode is attached to the first member.

13. The piezoelectric coupler of claim 7 wherein the second electrical connection includes a conductive member on the other wall of the piezoelectric component.

14. The piezoelectric coupler of claim 13 wherein the conductive member is a thin film.

15. The piezoelectric coupler of claim 13 wherein the second electrode is attached to the conductive member.

16. The piezoelectric coupler of claim 7 wherein the interference fit between the one wall of the piezoelectric cylinder and the surface of the first member increases in response to an increase in the voltage difference across the first and second electrodes.

17. The piezoelectric coupler of claim 7 wherein the piezoelectric component is a piezoelectric cylinder.

18. The piezoelectric coupler of claim 17 wherein the piezoelectric cylinder is surrounded by the surface of the first member.

19. The piezoelectric coupler of claim 7 including a voltage source having terminals for generating a voltage difference across the terminals, each electrode electrically connected to a different terminal, and a control system

operatively connected to the voltage source for selectively setting the voltage difference applied to the piezoelectric component.

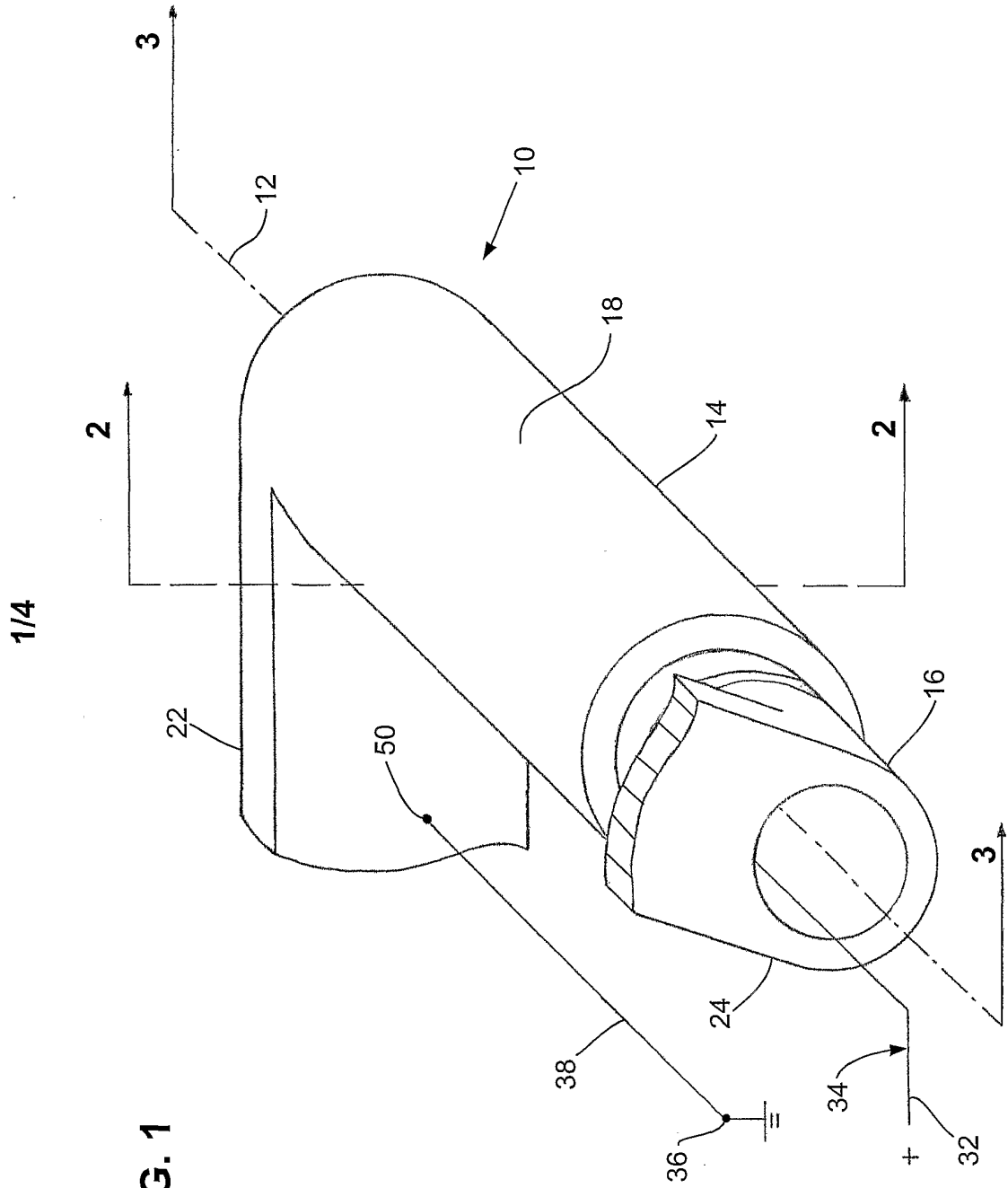


FIG. 1

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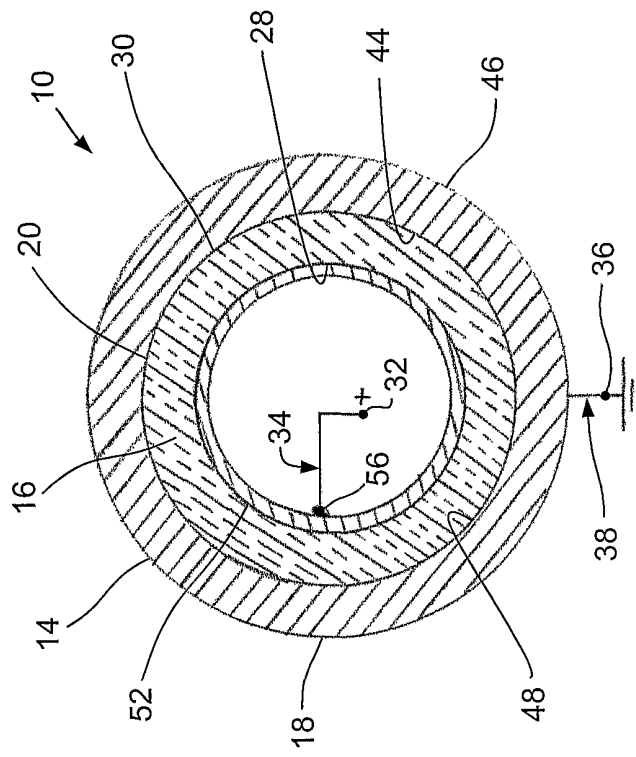


FIG. 2

INTERNATIONAL SEARCH REPORT

International application No.

PCT/US01/28826

A. CLASSIFICATION OF SUBJECT MATTER

IPC(7) : H01L 41/04, 08, 18; H02N 2/00; H03H 9/00
 US CL : 310/369, 328, 318, 330; 333/195

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
 U.S. : 310/369, 328, 318, 330, 313D, 313B, 313R, 322; 333/195, 153; 385/37, 31, 16;

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Y	US 5,229,980 A (PAWELA) 20 July 1993 (20.07.1993), Figure 3	1-6, 8-19
Y	US 4,519,751 A (BECKMAN et al.) 28 May 1985 (28.05.1985), Figures 4, 1	1-19
Y	US 4,593,956 A (CARUSO et al.) 10 June 1986 (10.06.1986), Figures 9.1, 9.2	1-19
Y	US 5,735,811 A (BRISKEN) 07 April 1998 (07.04.1998), Figures 2-4	1-3, 8-14
Y, E	US 6,323,567 B1 (HAZELTON et al.) 27 November 2001 (27.11.2001), Figure 2	1, 7

Further documents are listed in the continuation of Box C.

See patent family annex.

* Special categories of cited documents:			
"A"	document defining the general state of the art which is not considered to be of particular relevance	"T"	later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
"E"	earlier application or patent published on or after the international filing date	"X"	document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
"L"	document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)	"Y"	document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
"O"	document referring to an oral disclosure, use, exhibition or other means		
"P"	document published prior to the international filing date but later than the priority date claimed	"&"	document member of the same patent family

Date of the actual completion of the international search

03 December 2001 (03.12.2001)

Date of mailing of the international search report

09 JAN 2002

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INTERNATIONAL SEARCH REPORT

International application No.

PCT/US01/28826

Continuation of Item 4 of the first sheet:

Title is vague and does not describe the scope of the invention.

New suggested title:

Piezoelectric cylinder coupler for variably coupling two bodies and joint incorporating the coupler